

### Precession Diffraction: The Philospher's Stone of Electron Crystallography?

# Many methods exist for obtaining diffraction information

Focus

- Selected Area
- □ Nanodiffraction and variants

#### 

- All are complicated to interpret
- Reciprocal space is right, but intensities depend upon thickness, tilt etc

# We would like a method where not just the positions of the spots, but also the intensities could be used.

What PED can do

- Not rigorously equivalent to simple kinematical diffraction, but has many similarities
  - □ If the structure factor is large  $\rightarrow$  Intensity is large
  - Useful for fingerprinting structures
  - Often does not need calculations to interpret

#### History – Electron Precession (1993)

#### Double conical beam-rocking system for measurement of integrated electron diffraction intensities

R. Vincent, P.A. Midgley

H.H. Wills Physics Laboratory, University of Bristol, Tyndall Avenue, Bristol BS8 1TL, UK (Received 26 July 1993; in final form 4 October 1993)



#### Advantages:

- 1. PRECESSION -> MANY MORE REFLECTIONS INTERCEPTED BY EWALD SPHERE -> LARGE DATA SET
- 2. DIFFRACTED INTENSITIES DETERMINED BY INTEGRATING THROUGH BRAGG CONDITION → NO BRANCH STRUCTURE ... Ig → |Ug|<sup>2</sup> (NOT PARTIAL S.F.)
- 3. REDUCES NON-SYSTEMATIC DYNAMICAL EFFECTS

4. FOCUSSED PROBE -> HIGH SPATIAL RESOLUTION (~0-1, m)





### Precession System

#### US patent application:

"A hollow-cone electron diffraction system". Application serial number 60/531,641, Dec 2004.



#### SPINNING STAR: UNIVERSAL INTERFASE FOR PRECESSION ELECTRON DIFFRACTION FOR ANY TEM (120-200-300 KV)

• Can be easily retrofitable to any TEM 100- 300 KV

- precession is possible for any beam size 300 50 nm
- Precession is possible for a parallel or convergent beam

 precession eliminates false spots to ED pattern that belong to dynamical contributions

• precession angle can vary continuously (0°-3°) to observe true crystallographic symmetry variation

• Software ELD for easy quantification of ED intensities and automatic symmetry ( point, space group ) research



 Easily interfaced to electron diffractometer for automatic 3D structure determination



NanoMEGAS Advanced Tools for electron diffraction

# Examples:

- Complicated Structures
   Hard to interpret SAED
   Simple to interpret PED
- EDS
  - Elemental ratio's depend upon orientation in standard mode
  - □ Weak to no dependence with PED

#### **APPLICATION : FIND TRUE CRYSTAL SYMMETRY**



NanoMEGAS Advanced Tools for electron diffraction

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Courtesy M.Gemmi Univ of Milano

#### **APPLICATION : PERFECT CRYSTAL ORIENTATION**



Crystals –specially minerals -usually grow in platelet or fiber shape and results dificult to orient perfectly in a particular zone axis; in this example olivine crystals are perfectly oriented after precession is on.





# Carbide

# EDS, on zone (SrTiO<sub>3</sub>)



# Practical Use

- Two commercial systems (one hardware, another software) are available
- Not complicated, and could probably be written in scripting language
- Alignment can be tricky it always is
- Not rocket science to use

# Some Practical Issues

#### Projector Spiral Distortions (60 mRad tilt)



Bi-polar push-pull circuit (H9000)









C7

### **Optics**



### **Optics**



# One Consequence

- Prefield/Postfield displacements of beam  $d^{Pre} = 1/(2\pi) \nabla \chi^{Pre}(s-t^{Pre});$  s = Scan  $d^{Post}=1/(2\pi) \nabla \chi^{Post}(s-t^{Post}) - s^{D}\theta$   $s^{D} = DeScan$   $\nabla \chi(u)/(2\pi) = \Delta z \theta + C_{s} \theta^{3}$ Total apparent displacement is the sum
  - $d^{\text{Nett}} = d^{\text{Pre}} + d^{\text{Post}}$ 
    - $= \Delta z^{\text{Pre}}(\theta \theta^{\text{Pre}}) + \Delta z^{\text{Post}}(\theta \theta^{\text{Post}})$  $+ C_s^{\text{Pre}}(\theta - \theta^{\text{Pre}})^3 + C_s^{\text{Post}}(\theta - \theta^{\text{Post}})^3$  $-s^{\text{D}}\theta$

### Probe and Displacements (nm)

Prefield misalignment 1 mRad; Postfield -1.0 mRad



Caveat: this ignores 3fold astigmatism in pre/post field which is probably not appropriate, and any projector distortions



100 nm















### Alignment can be tricky



# Why?

Although PED has been around since 1992, and very actively used for ~10 years (mainly in Europe), there is *no* simple explanation (many have tried and failed)
Explanation is a bit rocket science

What, if any generalizations can be made? Role of Precession Angle Systematic Row Limit Importance of integration □ Phase insensitivity Important for which reflections are used □ Fast Integration Options

Why?



#### Precession integrates each beam over s<sub>z</sub>

- Full dynamical theory
  - All reciprocal lattice vectors are coupled and not seperable

Levels of theory

- Partial dynamical theory (2-beam)
  - Consider each reciprocal lattice vector dynamically coupled to transmitted beam only
- Kinematical theory
  - $\Box$  Consider only role of s<sub>z</sub> assuming weak scattering
- Bragg's Law
  - $\Box I = |F(g)|^2$

# $I_{obs}$ depends upon |F(g)|, g, $\phi$ (precession angle) which we "correct" to the true result Options:

Early Models

- 0) No correction at all,  $I=|F(g)|^2$
- 1) Geometry only (Lorentz, by analogy to xray diffraction) corresponds to angular integration
- 2) Geometry plus multiplicative term for |F(g)|

### Bragg's Law fails badly (Ga,In)<sub>2</sub>SnO<sub>5</sub>



# Kinematical Lorentz Correction

 $I(g) = \int |F(g) \sin(\pi t s_z)/(\pi s_z)|^2 ds_z$ 

s<sub>z</sub> taken appropriately over the Precession Circuit t is crystal thickness (column approximation)  $\phi$  is total precession angle  $I(g) = |F(g)|^2 L(g,t,\phi) \qquad L(g,t,\phi) = g \sqrt{1 - \left(\frac{g}{2R_0}\right)^2}$ 

K. Gjønnes, Ultramicroscopy, 1997.

### Kinematical Lorentz correction: Geometry information is insufficient



Need structure factors to apply the correction!

# 2-Beam (Blackman) form $I_{Blackman}(t) = \int_{0}^{A_{g}} J_{0}(2x) dx; A_{g}(k) \propto tF(k)$

Limits:

$$\begin{array}{l} A_g \text{ small}; I_{dyn}(k) \propto I_{kin}(k) \\ A_g \text{ large}; I_{dyn}(k) \propto \sqrt{I_{kin}(k)} = |F_{kin}(k)| \\ \text{But...} \end{array}$$

This assumes integration over all angles, which is not correct for precession (correct for powder diffraction)

# Blackman Form



The Blackman curve (Blackman [1939]) for the ratio of dynamical to kinematical intensities for a ring pattern as a function of  $A = \sigma H \Phi_h$ . The experimental points are those obtained by Horstmann and Meyer [1965], from measurements on ring patterns from aluminum films at various voltages. The short horizontal lines indicate values calculated using the Bethe potentials, equation (12). (After Horstmann and Meyer | 1965].)





Alas, little better than kinematical

#### **Two-Beam Form**

 $I(g) = \int |F(g) \sin(\pi t s^{eff}_z) / (\pi s^{eff}_z)|^2 ds_z$ s\_z taken appropriately over the Precession Circuit s\_z^{eff} = (s\_z^2 + 1/\xi\_g^2)^{1/2}  $\xi_g = \frac{\pi V_c \cos \theta_B}{\lambda F_o}$ 

Do the proper integration over  $s_z$ 

#### **Two-Beam Integration: Ewald Sphere**



### 2-Beam Integration better



### Some numbers



See Sinkler, Own and Marks, Ultramic. 107 (2007)

# Fully Dynamical: Multislice

- "Conventional" multislice (NUMIS code, on cvs)
- Integrate over different incident directions 100-1000 tilts
- $\phi = \text{cone semi-angle}$ 
  - $\bigcirc$  0 50 mrad typical
- t =thickness
  - $\square$  ~20 50 nm typical
  - □ Explore: 4 150 nm
- g = reflection vector
  - $\Box$   $|g| = 0.25 1 \text{ Å}^{-1}$  are structure-defining





### Multislice Simulation



Multislice simulations carried out using 1000 discrete tilts (8 shown) incoherently summed to produce the precession pattern<sup>1</sup>

#### How to treat scattering?

- 1) Doyle-Turner (atomistic)
- 2) Full charge density string potential -- later

# Multislice Simulation: works (of course)



### Global error metric: R<sub>1</sub>



- Broad clear global minimum atom positions fixed
- R-factor = 11.8% (experiment matches simulated known structure)

 $\Box$  Compared to >30% from previous precession studies

- Accurate thickness determination:
  - □ Average *t* ~ 41nm (very thick crystal for studying this material)

(Own, Sinkler, & Marks, in preparation.)

### Quantitative Benchmark: Multislice Simulation



(Own, Sinkler, & Marks, in preparation.)

#### Separable corrections fail; doing nothing is normally better

Partial Conclusions

- Two-beam correction is not bad (not wonderful)
- Only correct model is full dynamical one (alas)
- N.B., Other models, e.g. channelling, so far fail badly – the "right" approximation has not been found



- What, if any generalizations can be made?
- Role of Precession Angle
  - Systematic Row Limit
- Importance of integration
  - Phase insensitivity
  - □ Important for which reflections are used

### Role of Angle: Andalusite

- Natural Mineral
  - $\square Al_2SiO_5$
  - □ Orthorhombic (Pnnm)
    - **a**=7.7942
    - **b**=7.8985
    - **c**=5.559
  - □ 32 atoms/unit cell
  - Sample Prep
    - Crushm Disperse on holey carbon film
    - Random Orientation







[010]

### Measured and Simulated Precession patterns



32 mrad

 $[\overline{001}]$ 

[110]

### **Decay of Forbidden Reflections**

- Decay with increasing precession angle is exponential
  - □ The non-forbidden (002) reflections decays linearly
    - $I = A \exp(-D\phi)$

	D(001)	D(003)
Experimental	0.109 R <sup>2</sup> =0.991	0.145 R <sup>2</sup> =0.999
Simulated (102nm)	0.112 R <sup>2</sup> =0.986	0.139 R <sup>2</sup> =0.963
Simulated 28-126 nm	0.112±0.012	0.164±0.015



Rate of decay is relatively invariant of the crystal thickness

Slightly different from Jean-Paul's & Paul's – different case



#### **Forbidden, Allowed by Double Diffraction**



Rows of reflections arrowed should be absent ( $F_{hkl} = 0$ ) Reflections still present along strong systematic rows Known breakdown of Blackman model For each of the incident condition generate 50 random phase sets {f} and calculate patterns:



Single settings at 0, 12, 24 and 36 mrad (along arbitrary tilt direction).

Phase and Averaging

At fixed semi-angle (36 mrad) average over range of a as follows: 3 settings at intervals of 0.35° 5 settings at intervals of 0.35° 21 settings at intervals of 1°

For each **g** and thickness compute avg., stdev:

$$\overline{I}(\mathbf{g},t) = \frac{1}{50} \sum_{\{\varphi\}} I(\mathbf{g},t) \quad \sigma(\mathbf{g},t) = \left[\frac{1}{50} \sum_{\{\varphi\}} I(\mathbf{g},t)^2 - \overline{I}(\mathbf{g},t)^2\right]^{\frac{1}{2}}$$

### Phase independence when averaged



Sinkler & Marks, 2009

# Why does it work?

- If the experimental Patterson Map is similar to the Bragg's Law Patterson Map, the structure is solvable – Doug Dorset
- If the deviations from Bragg's Law are statistical and "small enough" the structure is solvable – LDM



### Automated Diffraction Tomography (ADT)

Most electron diffraction use TEM on-zone (oriented) patterns



ADT approach: collection of <u>full</u> <u>3D reciprocal space</u> starting from <u>not oriented patterns</u>







**Courtesy : Prof. U Kolb UMainz** 

### ADT concept



diffraction tomography. Part II – Cell parameter determination. U. Kolb, T. Gorelik and M.T. Otten, *Ultramicroscopy*, **108**, 763-772 (2008).

#### ASTAR (EBSD-TEM like)

#### Automatic Crystal Orientation/Phase mapping for TEM





www.nanomegas.com









Grenoble

7.50 µm = 50 steps IPF Map [101]







**NEW** precession application

"EBSD" – TEM





EBSD-TEM : beam is scanned over the sample (eg.  $10 \mu \times 10 \mu$ )



spot electron diffraction patterns are collected (<u>NOT</u> sensitive to stress/ strain or surface sample preparation like in EBSD-SEM)





Thousands of experimental spot ED patterns are acquired by a very fast optical CCD camera attached to TEM screen (180 patterns/sec)



Slow scan CCD can also be used (but slow : 20-30 patterns/sec)



Thousands of theoretical ED patterns are generated (templates) from .cif files or commercial databases for all known phases in a sample



Template matching is used (by cross-correlation of all experimental ED patterns with all templates) to generate most probable orientation of every scanned position in the sample.





#### Comparison SEM-(EBSD) vs TEM spatial resolution



#### **ASTAR : diffraction pattern adquisition**





#### EBSD-TEM : Automated Crystal Orientation Mapping



Bragg Spot pattern



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#### PED is

- Approximately Invertable
- Pseudo Bragg's Law
- □ Approximately 2-beam, but not great
- Properly Explained by Dynamical Theory

### PED is not

- □ Pseudo-Kinematical (this is different!)
- □ Fully Understood by Dummies, yet
- Important offshoots ADT and OIM



# Generate initial structure estimate Intial Bragg's Law Analysis or part of data

#### **Two-Beam Integration: Ewald Sphere**





Bragg's Law (reference)

Precession pattern (experiment)  $\phi = 24$ mrad

# Speculation...Full Method

Generate initial structure estimate
 Intial Bragg's Law Analysis or part of data
 Use 2-beam approximation to invert/correct
 Partial refinement, using 1/2 kpoint Bloch-Wave method

### Approximation of precession circuit by series of g-vector tilts:





=> increasingly accurate precession calculation

# **Precession calculations for (Ga,In)**<sub>2</sub>**SnO**<sub>5</sub>, 36 mrad semi-angle, increasing numbers of eigensolutions.



# Speculation...Full Method

- Generate initial structure estimate
   Intial Bragg's Law Analysis or part of data
   Use 2-beam approximation to invert/correct
   Partial refinement, using 1/2 kpoint Bloch-Wave method
  - Final full refinement using 25-100 beam BW (+Bethe terms, e.g. Stadleman or NUMIS + dmnf, large residual code)





### Questions ?